

DOCKET NO.: 285995US26PCT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF:

Kohei KAWAMURA, et al.

SERIAL NO: 10/567,733

GROUP: 2812

FILED: February 10, 2006

EXAMINER:

FOR: METHOD FOR FORMING FILM, METHOD FOR MANUFACTURING
SEMICONDUCTOR DEVICE, SEMICONDUCTOR DEVICE AND
SUBSTRATE TREATMENT SYSTEM

LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicant(s) submit a corrected Form PTO-1449 to replace the Form PTO-1449 filed on
August 2, 2007. Please note the correction of the document at row number AP.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,
MAIER & NEUSTADT, P.C.



Steven P. Weihrouck
Registration No. 32,829

Customer Number

22850

Tel. (703) 413-3000
Fax. (703) 413-2220
(OSMMN 03/06)

Paul J. Killos
Registration No. 58,014